

IN THE

Jeceil + #5 CFR 50avis 5/13/02

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

Tony P. Chiang et al.

TITLE:

Method for Integrated In-Situ Cleaning and Subsequent Atomic

Layer Deposition Within a Single Processing Chamber

SERIAL NO.:

09/994,279

FILING DATE:

November 26, 2001

EXAMINER:

Unknown

GROUP ART UNIT:

2812

ATTY.DKT.NO.:

PA1688US

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

TECHNOLOGY CENTER 2800

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REQUEST FOR CORRECTED FILING RECEIPT

SIR:

Applicants hereby request the United States Patent and Trademark Office correct its records and issue a corrected filing receipt showing the correct title of the invention. On the Filing Receipt, the word subsequent in the title is incorrectly spelled susequent. For reference purposes, Applicants enclose a copy of the incorrect filing receipt with the desired correction indicated in red ink. Applicants also enclose a copy of the Utility Patent Application Transmittal showing the correctly spelled title.

Since the paperwork submitted to the United States Patent and Trademark Office correctly indicated the spelling of the title, Applicants believe there is no fee for this request.

However, the Commissioner is hereby authorized to charge any additional fees which may be required to Deposit Account No. 06-0600. A copy of this letter is enclosed for this purpose.

Respectfully submitted,

Tony P. Chiang et al.

Dated: APRIL8, 2002

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on the date printed below:

Dated: APRILE 2002

Bradley W. Scheer, Reg. No. 47,059



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APPLICATION NUMBER FILING OATE GRP ART UNIT FIL FEE REC'O ATTY.OOCKET.NO **ORAWINGS TOT CLAIMS** INO CLAIMS 2812 388 **PA1688US** 11/26/2001

09/994,279

22830 **CARR & FERRELL LLP** 2225 EAST BAYSHORE ROAD SUITE 200 PALO ALTO, CA 94303



CONFIRMATION NO. 8825

FILING RECEIPT

"OC000000007172156"

Date Mailed: 12/07/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE. NAME OF APPLICANT, and TITLE OF INVENTION when inquining about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If y u received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Tony P. Chiang, Santa Clara, CA; Karl F. Leeser, Sunnyvale, CA;

Domestic Priority data as claimed by applicant

THIS APPLN CLAIMS BENEFIT OF 60/254,280 12/06/2000 AND CLAIMS BENEFIT OF 60/255,812 12/15/2000

Foreign Applications

If Required, Foreign Filing License Granted 12/07/2001

Projected Publication Date: 06/06/2002

Non-Publication Request: No

Early Publication Request: No

** SMALL ENTITY **

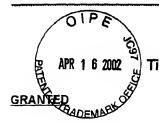
Title

subsequent

Method for integrated in-situ cleaning and susceptent atomic layer deposition within a single processing chamber

Preliminary Class

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